Attorney Docket No.: UNTD-0029 (122302.00012)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Tour et al.

Serial No.:

10/764,092

Filed:

January 23, 2004

Art Unit:

3742

Examiner:

Philip H. Leung

For:

PROCESS AND APPARATUS FOR MICROWAVE DESORPTION OF

ELEMENTS OR SPECIES FROM CARBON NANOTUBES

Mail Stop AF Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING UNDER 37 C.F.R. 1.8: I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on

RESPONSE UNDER 37 C.F.R. §1.116

EXPEDITED PROCEDURE
ART UNIT 3742

Signature

Printed Name

PARAMORE

AMENDMENT AFTER FINAL UNDER 37 C.F.R. §1.116

Devied pl 3/23/07

Responsive to the Final Office Action dated December 12, 2006, having a shortened statutory period for response expiring March 12, 207, please amend the above-identified patent application as follows: